MILITARY SPECIFICATION

SEMICONDUCTOR DEVICE, TRANSISTOR, PNP, GERMANIUM, LOW-POWER TYPE 2N466

This specification is mandatory for use by all Departments and Agencies of the Department of Defense.

1. SCOPE

- 1.1 Scope. This specification covers the detail requirements for a PNP, germanium, low-power transistor.
 - 1.2 Physical dimensions. See figure 1 (TO-5).
- 1.3 Maximum ratings.

P _T 1/	v _{CBO}	V _{CER}	v _{EBO}	T _{stg} and T _{op}
mW	Vdc	<u>V</u> dc	<u>Vdc</u>	<u>°C</u>
150	-35	-25	-12	-55 to +100

1/ Derate linearly 2 mW/°C for $T_A > 25$ °C.

1.4 Primary electrical characteristics.

Limits	h_{fe} $V_{CB} = -6 \text{ Vdc}$ $I_{E} = 1 \text{ mAdc}$	$f_{ m hfb}$ $V_{ m CB}:$ -6 Vdc $I_{ m E}=1$ mAdc	NF $V_{CB} = -2.5 \text{ Vdc}$ $I_E = 0.5 \text{ mAdc}$ $R_g = 100 \text{ ohms}$	C_{obo} $V_{\mathrm{CB}} = -6 \mathrm{Vdc}$ $I_{\mathrm{E}} = 0$ $100 \mathrm{kHz} \le f \le 1 \mathrm{MHz}$
Min Max	54 130	<u>MHz</u> 0.5 	<u>dB</u> 22	<u>pF</u> 60

2. APPLICABLE DOCUMENTS

2.1 The following documents, of the issue in effect on date of invitation for bids or request for proposal, form a part of the specification to the extent specified herein.

SPECIFICATION

MILITARY

MIL-S-19500 - Semiconductor Devices, General Specification for.

STANDARDS

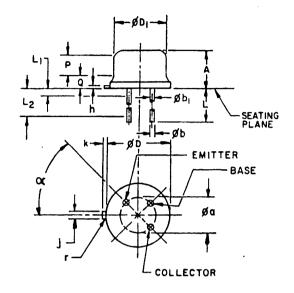
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* MIL-STD-202 - Test Methods for Electronic and Electrical Component Parts.
MIL-STD-750 - Test Methods for Semiconductor Devices.

(Copies of specifications, standards, drawings, and publications required by suppliers in connection with specific procurement functions should be obtained from the procuring activity or as directed by the contracting officer.)

3. REQUIREMENTS

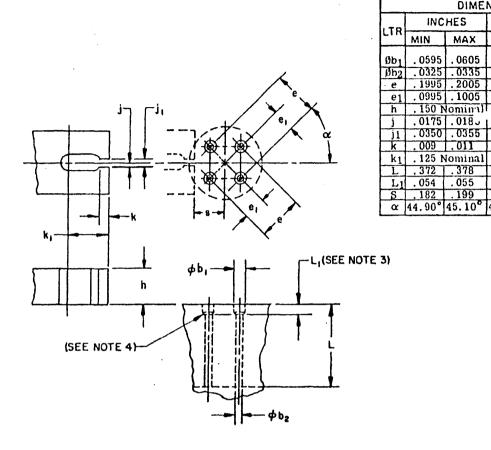
- 3.1 General. Requirements shall be in accordance with MIL-S-19500, and as specified herein.
- 3.2 Abbreviations, symbols, and definitions. The abbreviations, symbols, and definitions used herein are defined in MIL-S-19500.
- 3.3 Design, construction, and physical dimensions. Transistors shall be of the design, construction, and physical dimensions shown on figure 1.
- * 3.3.1 <u>Lead material and finish</u>. Lead material shall be Kovar or alloy 52. Lead finish shall be gold-plated. (Leads may be tin-coated if specified in the contract or order, and this requirement shall not be construed as adversely affecting the qualified-product status of the device, or applicable JAN marking (see 6.2)).
- * 3.3.1.1 Selectivity of lead material. Where choice of lead material (see 3.3.1 above) is desired, it shall be specified in the contract or order (see 6.2).
- 3.4 Performance characteristics. Performance characteristics shall be as specified in tables I, II, and $\overline{\text{III}}$.
- 3.5 Marking. The following marking specified in MIL-S-19500 may be omitted from the body of the transistor at the option of the manufacturer:
 - (a) Country of origin.
 - (b) Manufacturer's identification.



DIMENSIONS							
. 70	INC	HES	MILLIM	NOTES			
LTR	MIN	MAX	MIN	MAX	Š		
A	. 240	. 260	6. 10	6.60			
Øa	. 200		5.0		6		
Øb	.016	. 021	. 41	. 53	7, 8		
Øb1	.016	.019	. 41	. 48	7, 8		
ØD	. 335	. 370	8.51	9.40			
ØD1	. 305	. 335	7.75	8.51			
h	.009	.041	. 23	1.04			
j	. 028	. 034	. 71	. 86	2		
k	. 029	. 045	. 74	1.14	3		
L	1.500	1.750	38.10	44.45	7, 8		
L_1		. 050		1.27	7, 8		
L ₂	. 250	1	6.35		7, 8		
P	. 100		2,54		5		
િ	~	. 050		1.27	4		
r		.010		. 25	10		
α	45	тP	45	TP	6		

NOTES:

- 1. Metric equivalents (to the nearest .01 mm) are given for general information only and are based upon 1 inch = 25.4 mm.
- 2. Beyond r(radius) maximum, j shall be held for a minimum length of .011(.28 mm).
- 3. k measured from maximum ØD.
- 4. Outline in this zone is not controlled.
- 5. ØD1 shall not vary more than .010(.25 mm) in zone P. This zone is controlled for automatic handling.
- 6. Leads at gage plane . 054 + .001-.000(1.37+.03-.00 mm) below seating plane shall be within .007(.18 mm) radius of true position (TP) at maximum material condition (MMC) relative to tab at MMC. The device may be measured by direct methods or by the gage and gaging procedure shown in figure 2.
- Øb1 applies between L1 and L2. Øb applies between L2 and L minimum. Diameter is uncontrolled in L1 and beyond L minimum.
- 8. All three leads.
- 9. All leads electrically insulated from the case.
- 10. r(radius) applies to both inside corners of tab.
 - * FIGURE 1. Physical dimensions of transistor type 2N466 (TO-5).



NO	T	r	c	,

- 1. The location of the tab locator within the limits indicated will be determined by the tab and flange dimensions of the device being checked.
- 2. The following gaging procedure shall be used:

The device being measured shall be inserted until its scating plane is .125(3.18 mm) \pm .010(.25 mm) from the seating surface of the gage. A force of 8 \pm .5 oz shall then be applied parallel and symmetrical to the device's cylindrical axis. When examined visually after the force application (the force need not be removed) the seating plane of the device shall be seated against the gage.

DIMENSIONS

MIN

1.51

. 83

. . 07

2,53

. 44

89

4.62

. 23

MILLIMETERS

3.81 Nomina

3.18 Nomina

9.45 | 9.60 1.37 | 1.40

44.90 45.10

MAX

1.54

. 85

5.09

2,55

. 46

.90

. 28

5.05

INCHES

.009 | .011

182

. 055

. 199

0595

MAX

. 0605

The use of a pin straightener prior to insertion in the gage is permissible.

- Gaging plane.
- Drill angle.

FIGURE 2. Gage for lead and tab location for transistor type 2N466.

TABLE I. Group A inspection

_	,,	MIL-STD-750		·	Li	mits	:
Examination or test	Method	Details	LTPD	Symbol	Min	Мах	Unit
Subgroup 1	:		10		_		
Visual and mechanical examination	2071	·					
Subgroup 2			5				
Breakdown voltage, collector to base	3001	Bias condition D: $I_C = -10 \mu Adc$		вусво	-35		Vdc
Breakdown voltage, collector to emitter	3011	Bias condition B; $I_C = -600 \mu \text{Adc}$: $R_{BE} = 10 \text{kilohms}$		BVCER	-25		Vdc
Emitter to base cutoff current	3061	Bias condition D: V _{EB} = -12 Vdc		IEBO		-12	μAdc
Collector to base cutoff current	3036	Bias condition D: V _{CB} = -35 Vdc		I _{CBO}		-20	μ A dc
Subgroup 3		·	15				
Small-signal short-circuit forward-current transfer ratio	3206	VCB = -6 Vdc: I _E = 1 mAdc		h _{fe}	54	130	
Small-signal short-circuit forward-current transfer ratio cutoff frequency	3301	V _{CB} = -6 Vdc; I _E = 1 mAdc		^f hfb	0.5		MHz
Open circuit output capacitance	323 6	$V_{CB} = -6 \text{ Vdc}: I_E = 0:$ $100 \text{ kHz} \le f \le 1 \text{ MHz}$		Соро		60	рF
Small-signal short-circuit input impedance	3201	$V_{CB} = -6 \text{ Vdc}$; $I_E = 1 \text{ mAdc}$		h _{ib}	18	45	ohms
Small-signal open-circuit output admittance	3216	V _{CB} = -6 Vdc: I _E = 1 mAdc		h _{ob}		1	μmho
Noise figure	3246	V_{CB} = -2.5 Vdc; I_E = 0.5 mAdc; R_L = 100 kilohms; R_g = 100 ohms		NF		22	dB
Subgroup 4		•	15				
High-temperature operation:		$T_A = +71^{\circ}C$					
Collector to base cutoff current	3036	Bias condition D: V _{CB} = -12 Vdc		I _{CBO}		-100	μAdc
Small-signal short-circuit forward-current transfer ratio	3206	$v_{CB} = -6 \text{ Vdc}; I_E = 1 \text{ mAdc}$		^h fe		250	
Low-temperature operation:		$T_A = -55$ °C					
Small-signal short-circuit forward-current transfer ratio	3206	V _{CB} = -6 Vdc: I _E = 1 mAdc		h _{fe}	25		

TABLE II. Group B inspection

		MIL-STD-750			Li	mits	
Examination or test	Method	Details	LTPD	Symbol	Min	Max	Unit
Subgroup 1			20				
Physical dimensions	2066	See figure 1					
* Subgroup 2			15				
Solderability	2026						
Thermal shock (temperature cycling)	1051	Test condition A, except in step 3; $T_{A} = +100^{\circ} + 5^{\circ}_{-0} C$					
Thermal shock (glass strain)	1056	Test condition A					
Hermetic seal	1071	Test condition G or H for fine leaks; test condition A, C, D, or F for gross leaks				1x10 ⁻⁷	atm cc/s
Moisture resistance	1021						
End points:		•					
Collector to base cutoff current	3036	Bias condition D; V _{CB} = -35 Vdc		I _{CBO}		-20	μAdc
Small-signal short-circuit forward-current transfer ratio	3206	V _{CB} = -6 Vdc; I _E = 1 mAdc		^h fe	54	130	
* Subgroup 3			15				
Shock	2016	Nonoperating; 1,500 G, for 0.5 ms, 5 blows in each orientation: X_1 , Y_1 , Y_2 , and Z_1					
Vibration, variable frequency	2056						
Constant acceleration	2006 ⁱ	20,000 G; in each orientation: X_1 , Y_1 , Y_2 , and Z_1					
End points: (Same as subgroup 2)							
* Subgroup 4			20				
Terminal strength (lead fatigue)	2036	Test condition E					
End points:							
Hermetic seal	1071	Test condition G or H for fine leaks; test condition A, C, D, or F for gross leaks				1x10 ⁻⁷	atm cc [/] s

TABLE II. Group B inspection -Continued

Examination or test		MIL-STD-750			Li	mits	
	Method	Details	LTPD	Symbol	Min	Max	Unit
* Subgroup 5			20				
Salt atmosphere (corrosion)	1041						
* Subgroup 6			10				
High-temperature life (nonoperating)	1032	T _{stg} = +100°C (see 4.3.4)					
End points:							
Collector to base cutoff current	3036	Bias condition D; V _{CB} = -35 Vdc		I _{CBO}		-25	μAdc
Small-signal short-circuit forward-current transfer ' ratio	3206	V_{CB} = -6 Vdc; I_{E} = 1 mAdc		h _{fe}	44	150	
* Subgroup 7		•	10				
Steady-state operation life	1027	P _T = 150 mW; V _{CB} = -35 Vdc (see 4.3.4)					
End points: (Same as subgroup 6)							

TABLE III. Group C inspection

TABLE III. Group C inspection							
Examination or test		MIL-STD-750			Li	mits	
	Method	Details	LTPD	Symbol	Min	Max	Unit
* Subgroup 1			10				
Resistance to solvents		MIL-STD-202, Method 215 (see 4.4.1)					
* Subgroup 2			λ = 10		<u> </u>		
High-temperature life (nonoperating)	1031	$T_{stg} = +100 ^{\circ} C$ (see 4.3.4)					
End points: (Same as subgroup 6 of group B)							
* Subgroup 3		l İ	λ = 10				
Steady-state operation life	1026	P _T = 150 mW; V _{CB} = -35 Vdc (see 4.3.4)	·				
End points: (Same as subgroup 6 of group B)							

- 4. QUALITY ASSURANCE PROVISIONS
- 4.1 Sampling and inspection. Sampling and inspection shall be in accordance with MIL-S-19500, and as specified herein.
- 4.2 Qualification inspection. Qualification inspection shall consist of the examinations and tests specified in tables I, II, and III.
- 4.3 Quality conformance inspection. Quality conformance inspection shall a sist of group A, B, and C inspections.
- 4.3.1 Group A inspection. Group A inspection shall consist of the examinations and tests specified in table I.
- 4.3.2 Group B inspection. Group B inspection shall consist of the examinations and tests specified in table II.
- 4.3.3 Group C inspection. Group C inspection shall consist of the tests specified in table III. This inspection shall be conducted on the initial lot and thereafter every 6 months during production.
- * 4.3.4 Group B and group C life-test samples. Samples that have been subjected to group B, 340-hour life-test, may be continued on test to 1,000 hours in order to satisfy group C life-test requirements. These samples shall be predesignated, and shall remain subjected to the group C, 1,000-hour acceptance evaluation after they have passed the group B, 340-hour acceptance criteria. The cumulative total of failures found during 340-hour test and during the subsequent interval up to 1,000 hours shall be computed for 1,000-hour acceptance criteria, see 4.3.3.
- 4.4 Methods of examination and test. Methods of examination and test shall be as specified in tables I, II, and III, and as follows:
- * 4.4.1 Resistance to solvents. Transistors shall be subjected to tests in accordance with method 215 of MIL-STD-202. The following details shall apply:
 - (a) All areas of the transistor body where marking has been applied shall be brushed.
 - (b) After subjection to the tests, there shall be no evidence of mechanical damage to the device and markings shall have remained legible.
 - 5. PREPARATION FOR DELIVERY
 - 5.1 See MIL-S-19500, section 5.
 - 6. NOTES
 - 6.1 Notes. The notes specified in MIL-S-19500 are applicable to this specification.
- * 6.2 Ordering data.
 - (a) Lead finish if other than gold-plated (see 3.3.1).
 - (b) Selectivity of lead material (see 3.3.1.1).
- 6.3 Changes from previous issue. The margins of this specification are marked with an asterisk to indicate where changes (additions, modification, corrections, deletions) from the previous issue were made. This was done as a convenience only and the Government assumes no liability whatsoever for any inaccuracies in these notations. Bidders and contractors are cautioned to evaluate the requirements of this document based on the entire content irrespective of the marginal notations and relationship to the last previous issue.

Custodians: Army - EL Navy - EC Air Force - 17

Review activities: Army - MU, MI Air Force - 11, 80 DSA - ES

User activities: Army - AV, SM Navy - AS, CG, MC, OS, SH Air Force - 13, 15, 19 Preparing activity: Army - EL

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(Project 5961-0297)

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